

Title of the Invention: Simplified Reticle Stage
Removal System for an Electron
Beam System
Inventor's Name: Novak et al.
Docket No./Application No.: 10/056,017

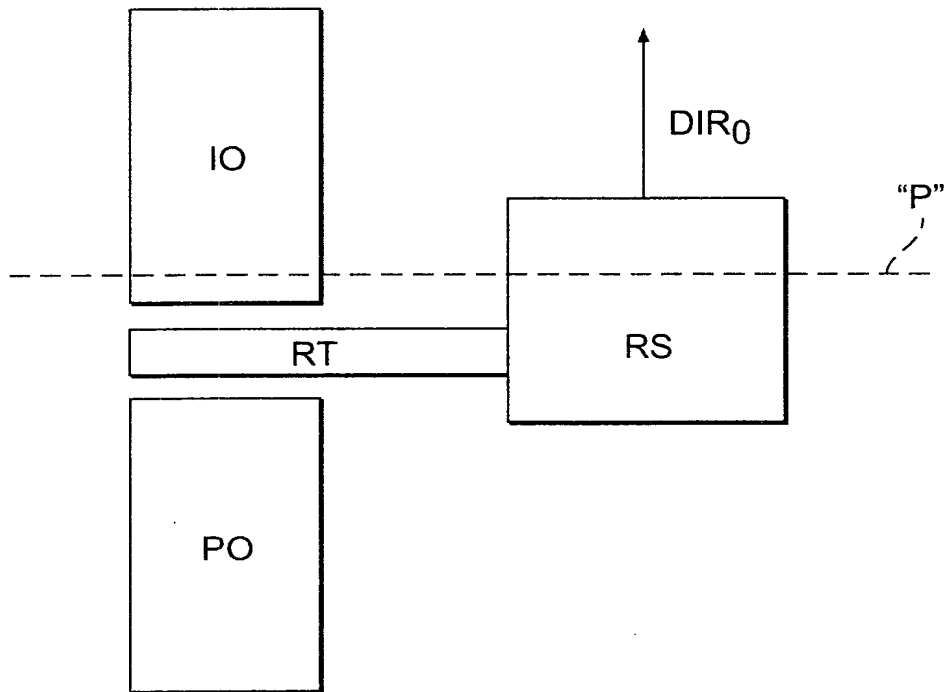


FIG. 1



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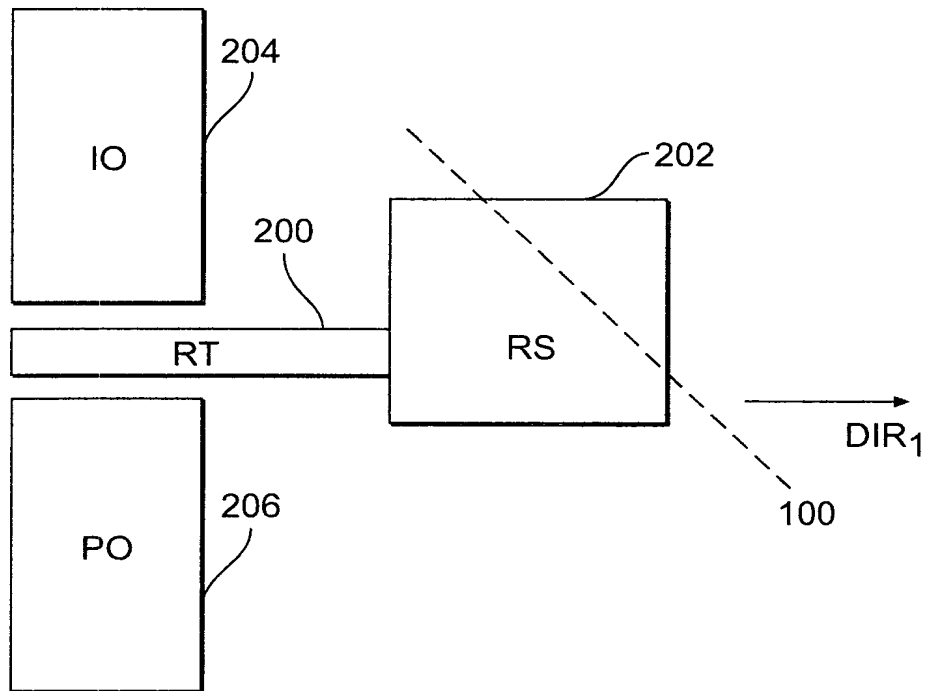
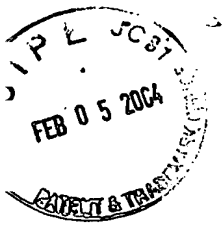


FIG. 2



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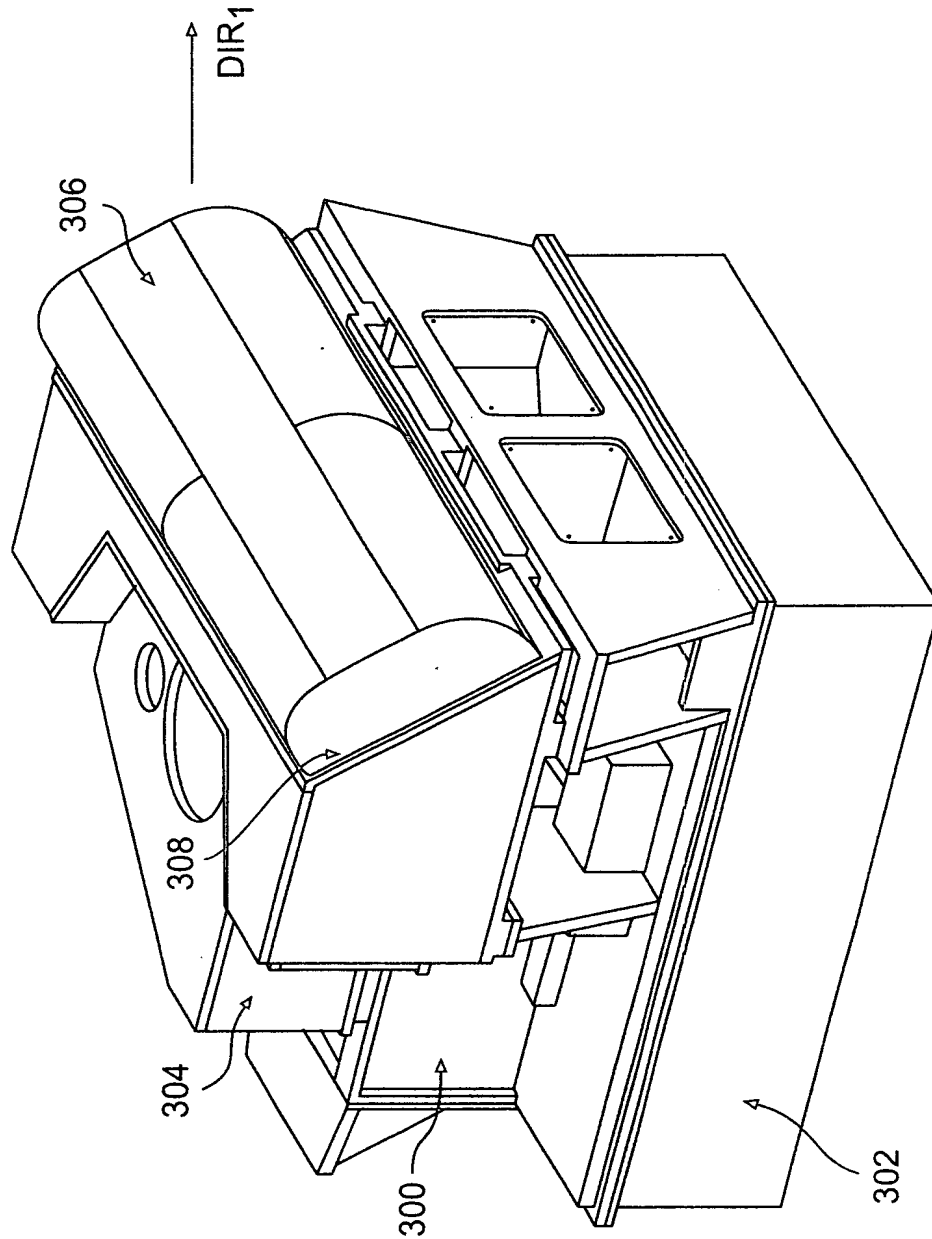


FIG. 3

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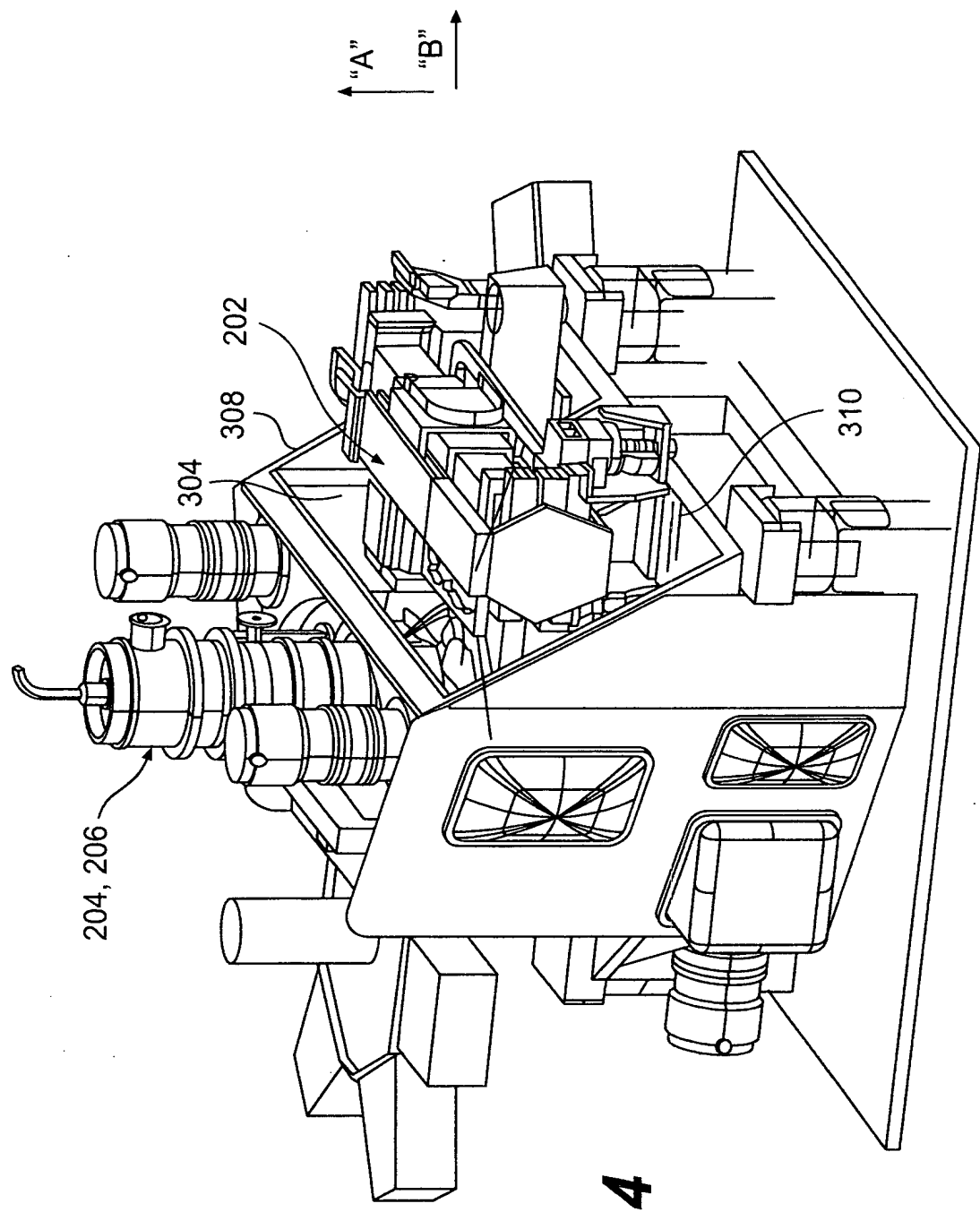
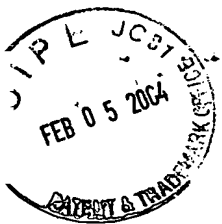


FIG. 4



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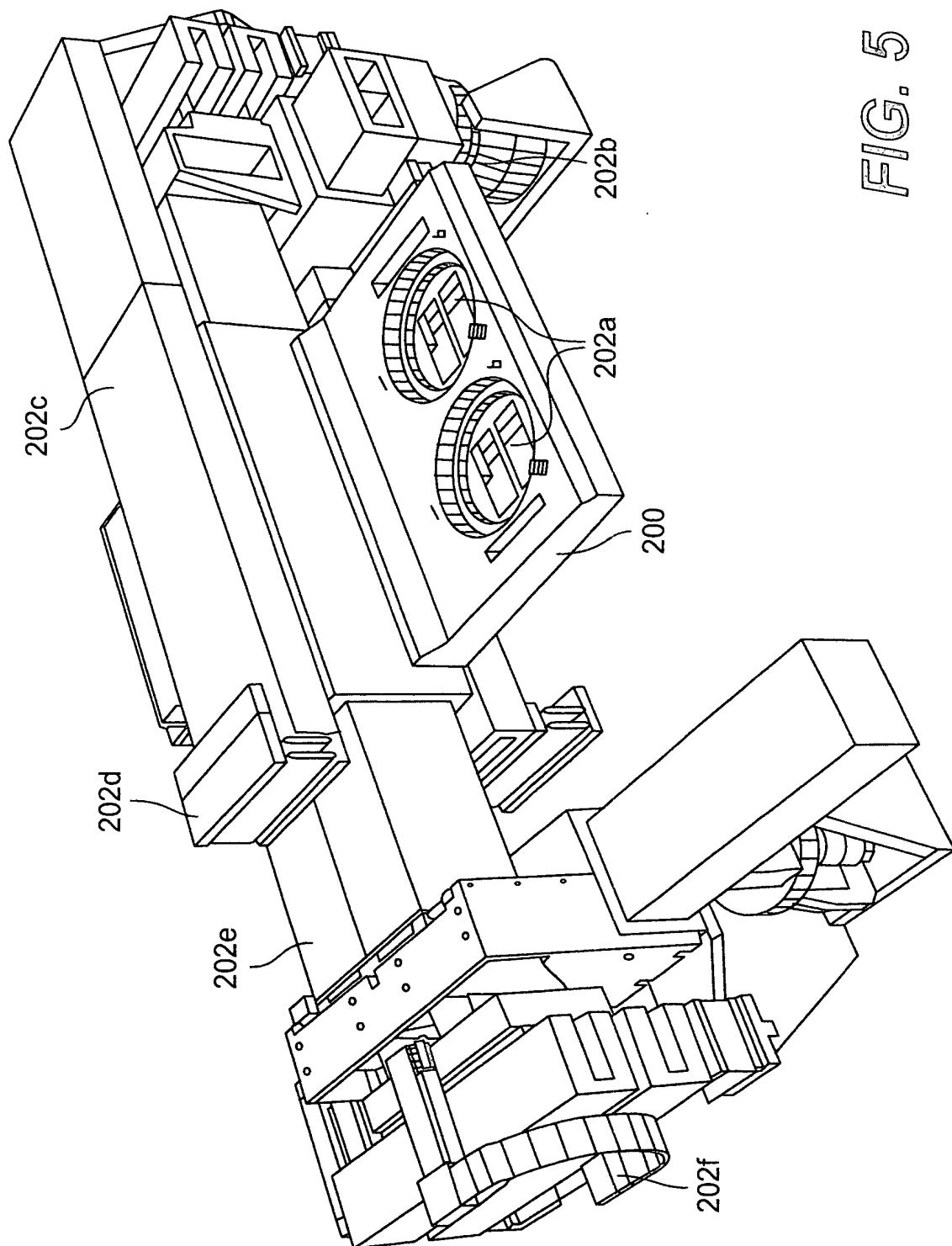


FIG. 5